

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Yasuhiro KOIZUMI et al

Art Unit: 2877

S.N. 09/920,450

Examiner: J. Valentin

Filed: August 1, 2001

For: DEFECT INSPECTION APPARATUS
FOR PHASE SHIFT MASK

R E S P O N S E

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated December 31, 2002,
for which a three month extension of time is requested, to extend
the period for response to June 30, 2003, please amend the above-
identified application as follows:

FAX RECEIVED

JUN 30 2003

TECHNOLOGY CENTER 2800